



# JOURNAL OF EMERGING TECHNOLOGIES AND INNOVATIVE RESEARCH (JETIR)

An International Scholarly Open Access, Peer-reviewed, Refereed Journal

Ref No : JETIR / Vol 6 / Issue 5 / 041

## Confirmation Letter

To,  
Steffi Mary Peter  
Published in : Volume 6 | Issue 5 | 2019-05-01



**Subject:** Publication of paper at International Journal of Emerging Technologies and Innovative Research .

Dear Author,

With Greetings we are informing you that your paper has been successfully published in the International Journal of Emerging Technologies and Innovative Research (ISSN: 2349-5162). Following are the details regarding the published paper.

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Registration ID : JETIR 217773

Paper ID : JETIRCV06041

Title of Paper : Error Masking Technique For Register File In Xilinx FPGA

Impact Factor : 7.95 (Calculate by Google Scholar)

DOI :

Published in : Volume 6 | Issue 5 | 2019-05-01

Publication Date: 2019-05-01

Page No : 207-212

Published URL : <http://www.jetir.org/view?paper=JETIRCV06041>

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Thank you very much for publishing your article in JETIR. We would appreciate if you continue your support and keep sharing your knowledge by writing for our journal JETIR.

  
Editor In Chief

International Journal of Emerging Technologies and Innovative Research  
(ISSN: 2349-5162)



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